



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akihiko HARADA, et al.**

Confirmation No: **2927**

Serial No.: **09/717,143**

Group Art Unit: **2826**

Filed: **November 22, 2000**

Examiner: **Ahmed N. Sefer**

Customer No.: **38834**

For: **INSULATED GATE TYPE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING SAME**

**AMENDMENT UNDER 37 CFR §1.116**

**-EXPEDITED RESPONSE-**  
**GROUP ART UNIT 2826**

**Box: AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**March 5, 2004**

Sir:

In response to the Office Action dated November 7, 2003, please amend the above-identified application as follows: